

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Jifa Hao, et al.

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September 1, 2000Examiner
Ori NadavGroup Art Unit
2811**Invention: POWER SEMICONDUCTOR DEVICE WITH HIGH AVALAN CHE CAPABILITY AND PROCESS****FOR FORMING SAME**I hereby certify that this Amendment (total 4 pages)*(Identify type of correspondence)*

is being deposited with the United States Postal Service as first class mail in an envelope addressed to:

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